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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known							
Application Number	Application Number 09/544,799						
Filing Date	April 7, 2000						
First Named Inventor	Levitan						
Group Art Unit	2872						
Examiner Name	Shafer, R.						
Attorney Docket Number	1026-017/MMM						

				U.S. PATENT DOCU	IMENTS	
Examiner Initials*	is No 1 Number Kind Code ²			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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	Examiner Signature R.D. J.	Date Considered	8	107	/2005
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Group Art Unit Examiner Name

First Named Inventor

Application Number

Filing Date

2872 Shafer, R. **Attorney Docket Number** 1026-017/MMM

Levitan

Complete if Known

09/544,799

April 7, 2000

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	_
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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Form 1	РТО	-1449 Modified	Docket No. MSFT-3943/127340.01	Application No. 09/544,799				
c	cited b	t and Publications by Applicant sheets if necessary)	Applicant Jeremy A. Levitan, et al.					
}	•	nent of Commerce Frademark Office	Filing Date April 7, 2000	Group 2872				
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	Cite	tent and Publications d by Applicant al sheets if necessary		Applicant Jeremy A. Levitan, et al.			
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				Confirmation No. 1559			
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Form PTO-1449 Modified List of Patent and Publications Cited by Applicant (Use several sheets if necessary)				Docket No. MSFT-3943/127340.01 Application No. 09/544,799 Applicant Jeremy A. Levitan, et al.		
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